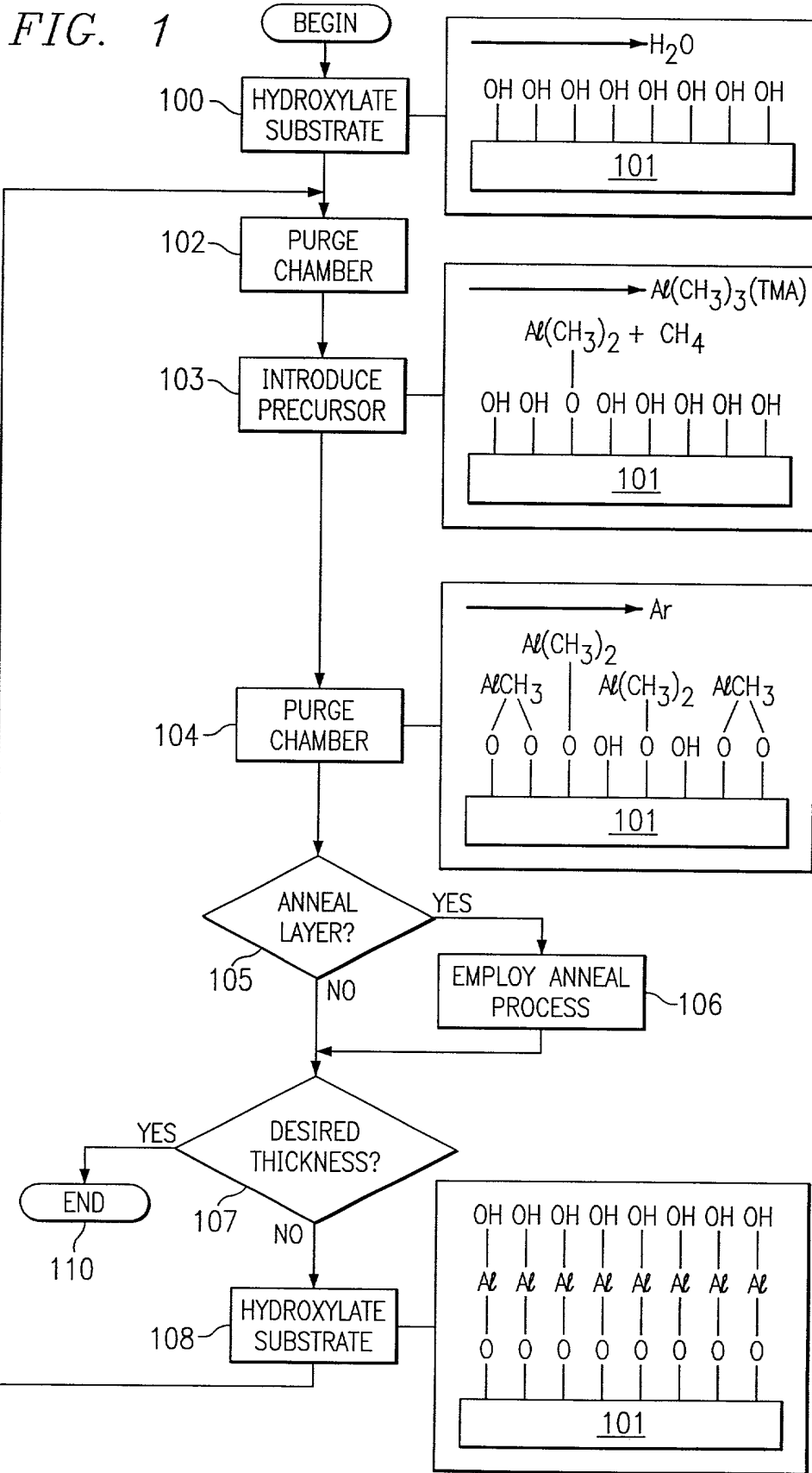


# ATOMIC LAYER DEPOSITION FOR FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

Express: EL740056656US Docket: 021208.0238

1/7



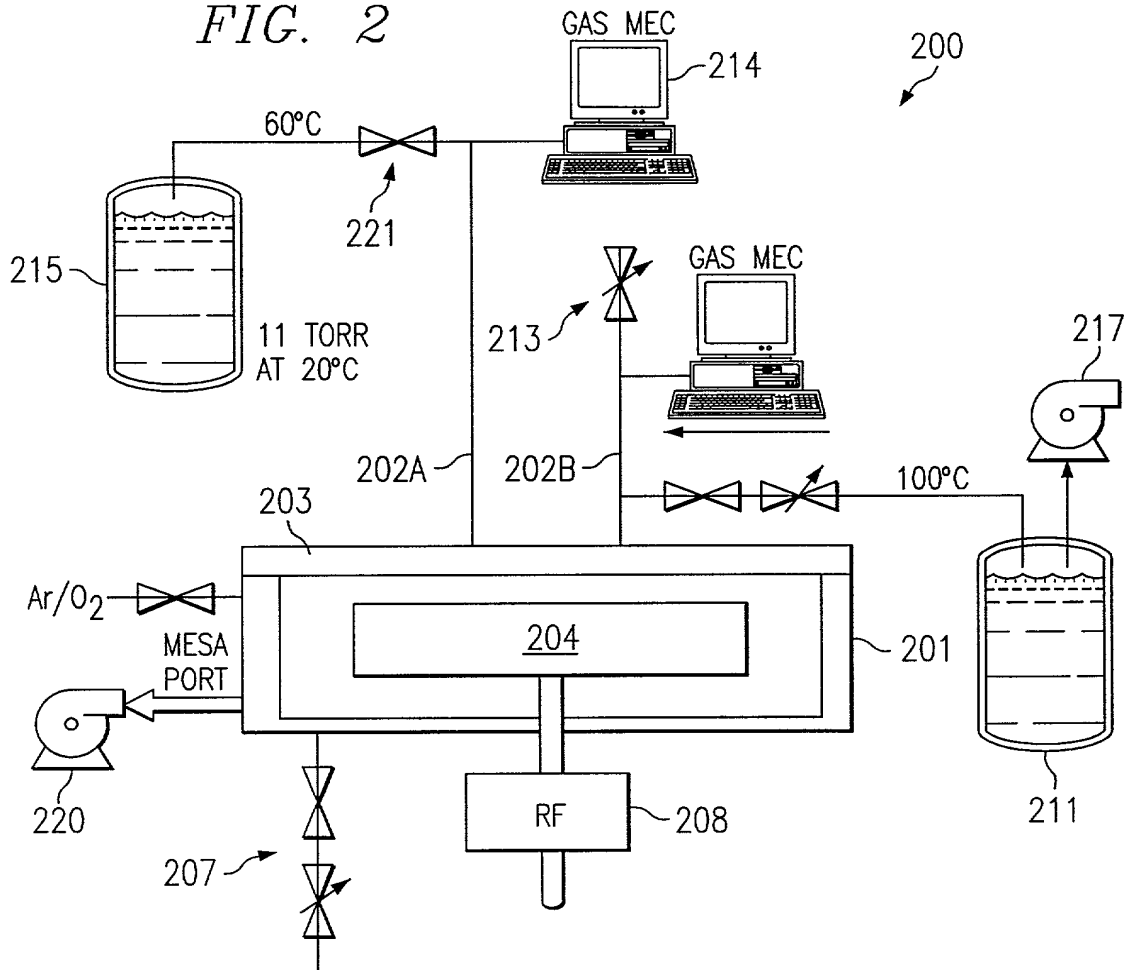
# ATOMIC LAYER DEPOSITION FOR FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

Express: EL740056656US Docket: 021208.0238

2/7

FIG. 2



300

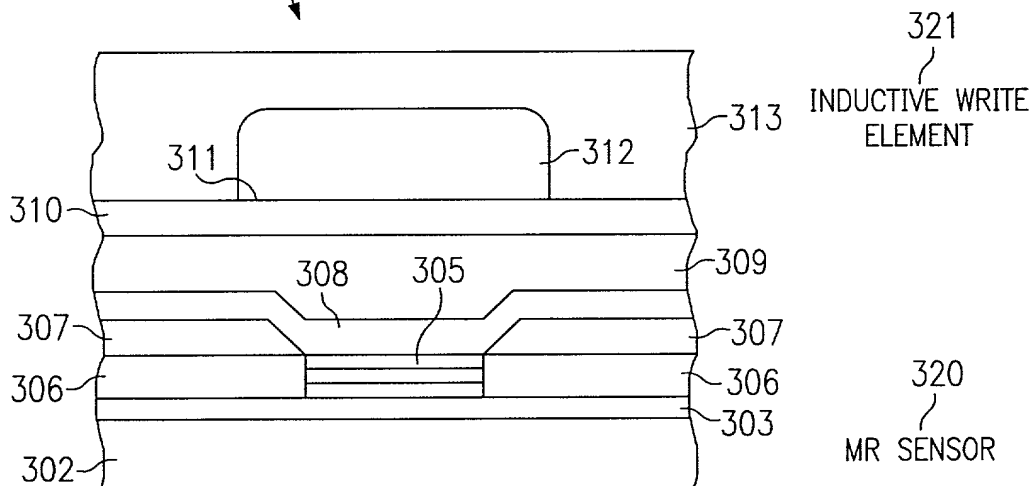


FIG. 3

ATOMIC LAYER DEPOSITION FOR  
FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

Express: EL740056656US Docket: 021208.0238

3/7

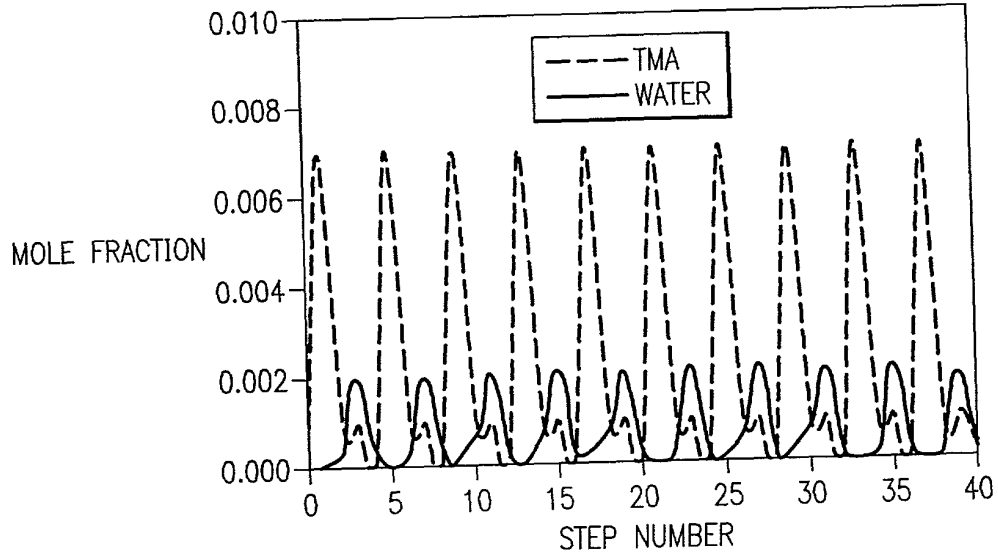


FIG. 4

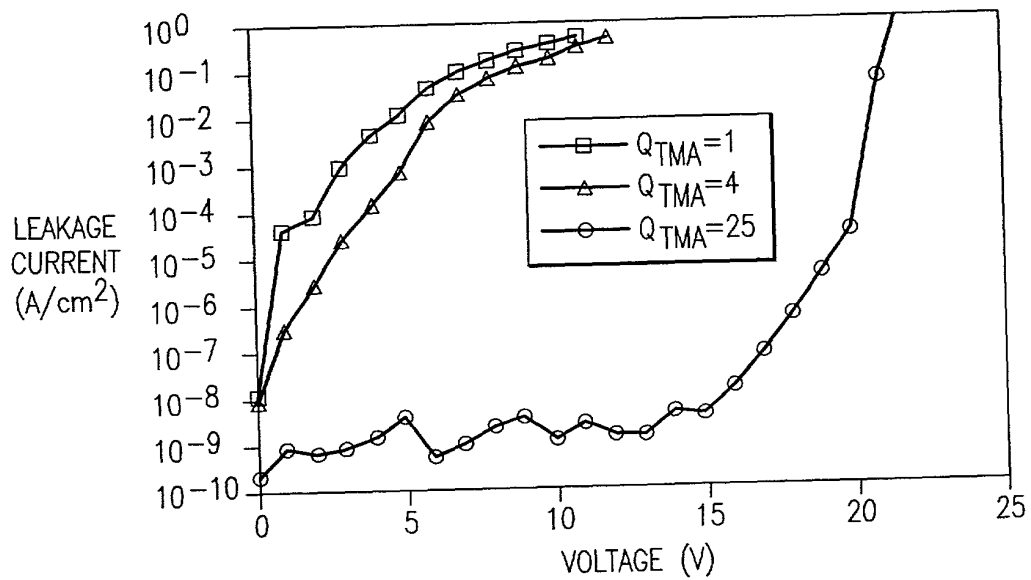


FIG. 5

ATOMIC LAYER DEPOSITION FOR  
FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

Express: EL740056656US Docket: 021208.0238

4/7

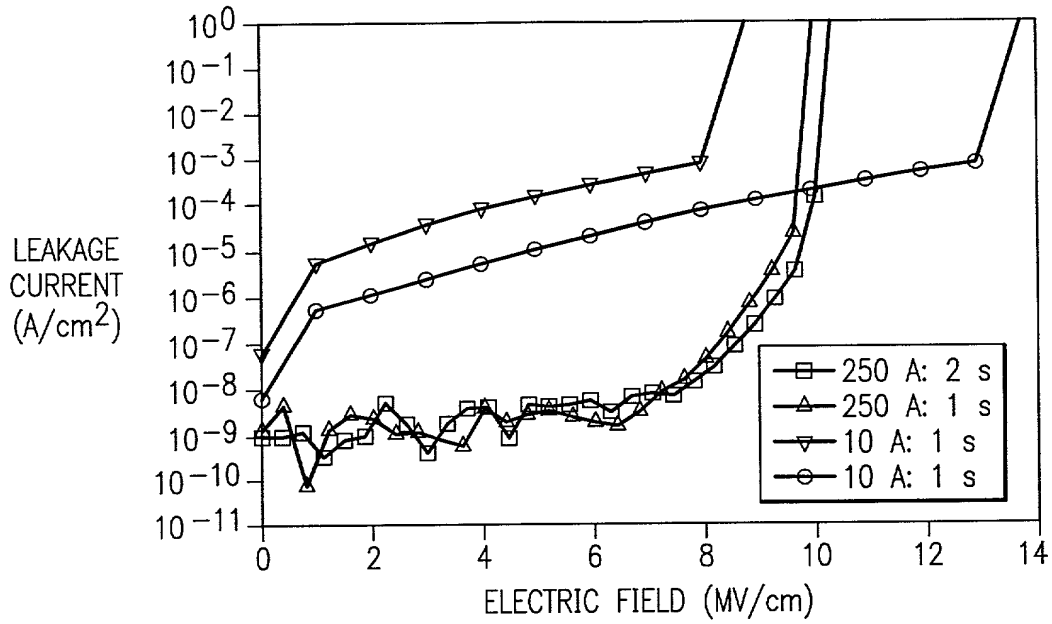


FIG. 6

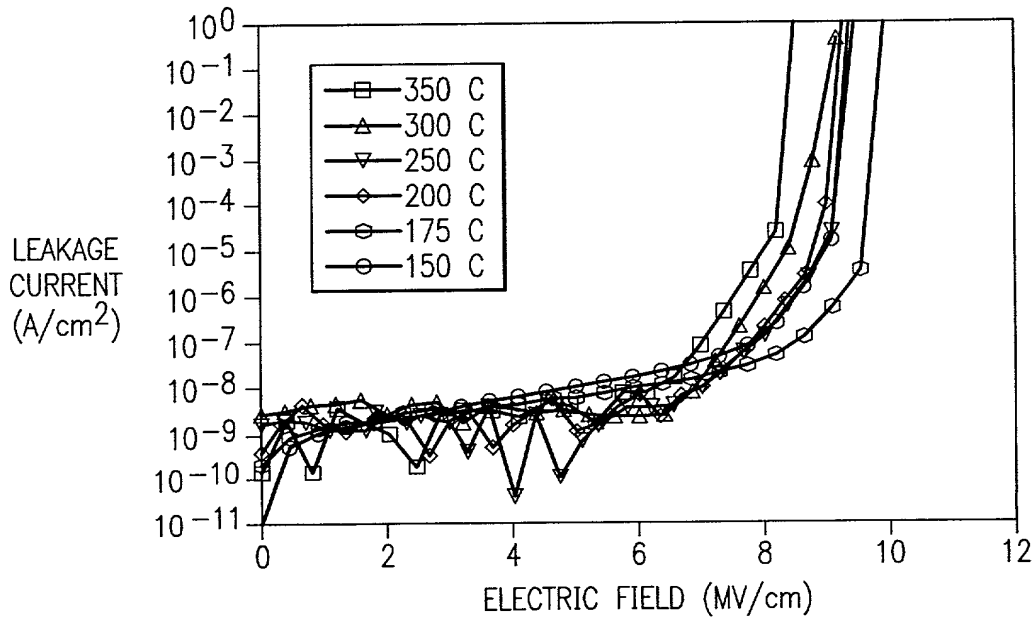


FIG. 7

TOMIC LAYER DEPOSITION FOR  
ABRICATING THIN FILMS

inventor: Ajit P. Paranjpe, et al.  
express: EL740056656US Docket: 021208.0238

5/7

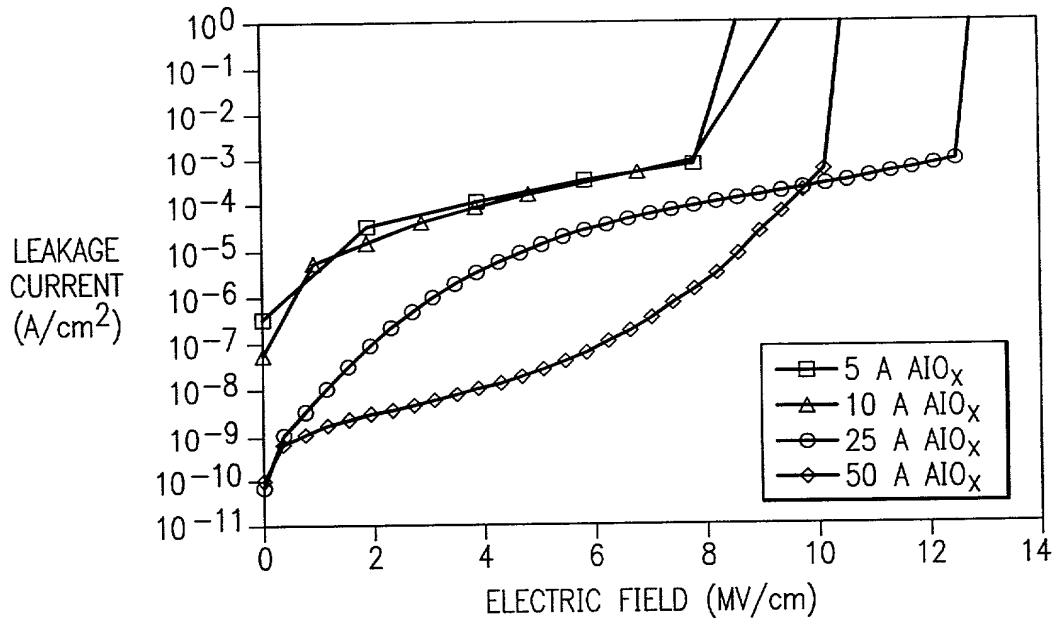


FIG. 8A

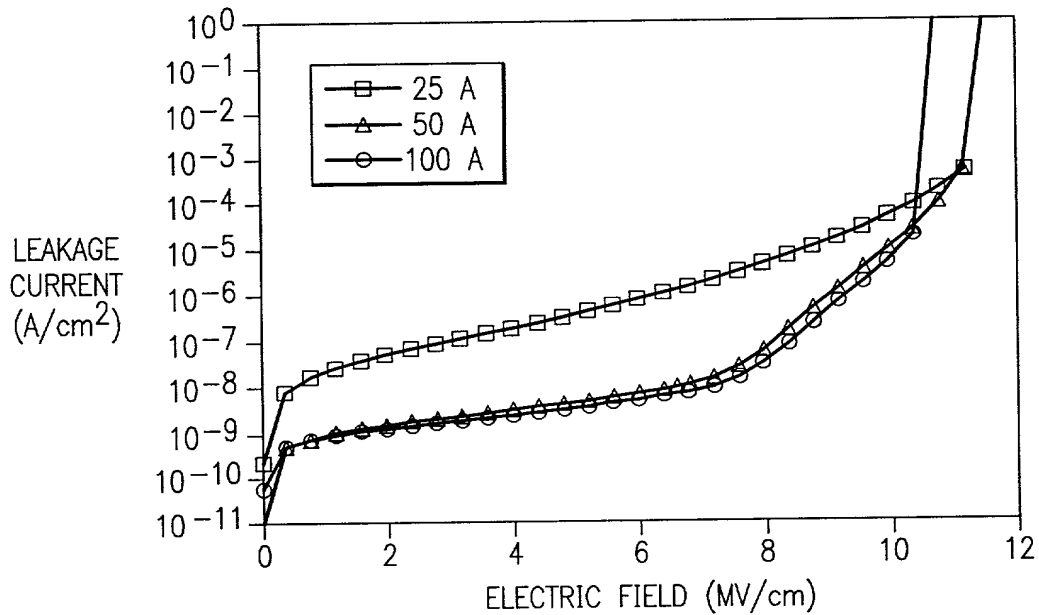


FIG. 8B

ATOMIC LAYER DEPOSITION FOR  
FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

Express: EL740056656US Docket: 021208.0238

6/7

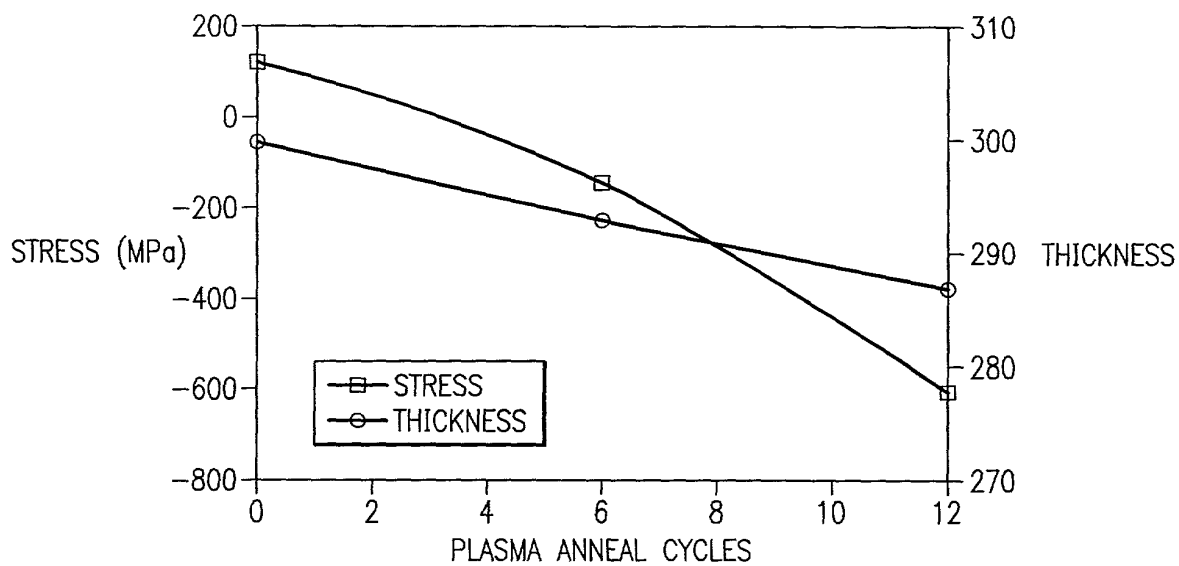


FIG. 9

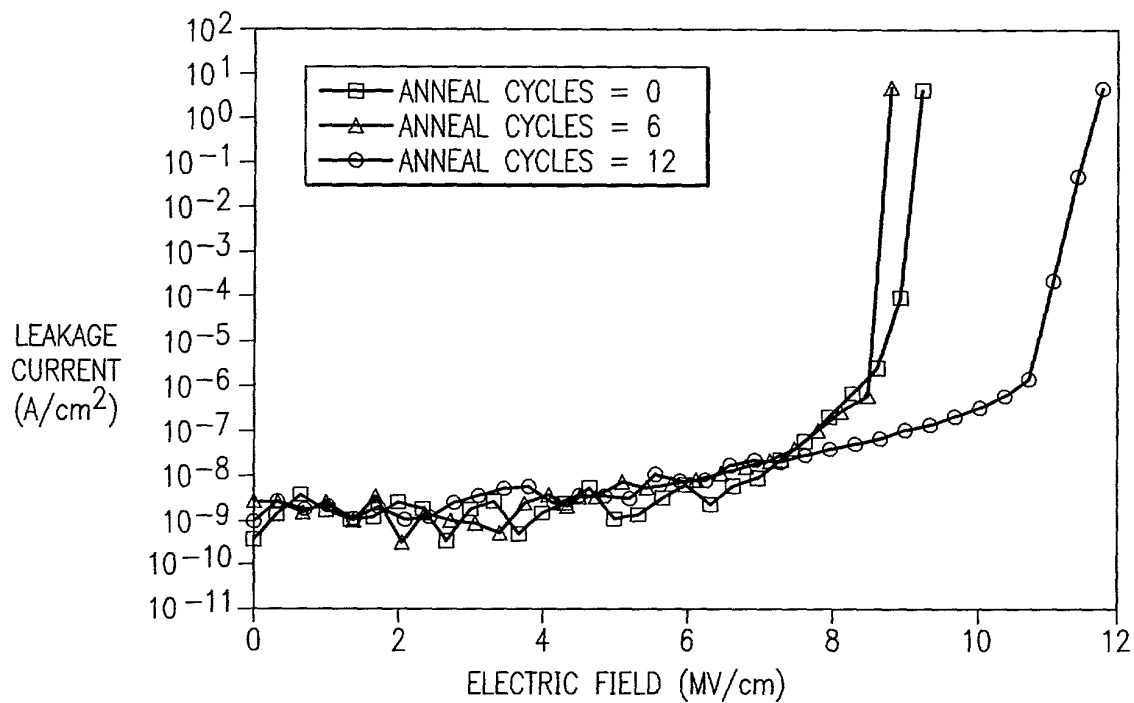


FIG. 10

TOMIC LAYER DEPOSITION FOR  
ABRICATING THIN FILMS

inventor: Ajit P. Paranjpe, et al.  
xpress: EL740056656US Docket: 021208.0238

7/7

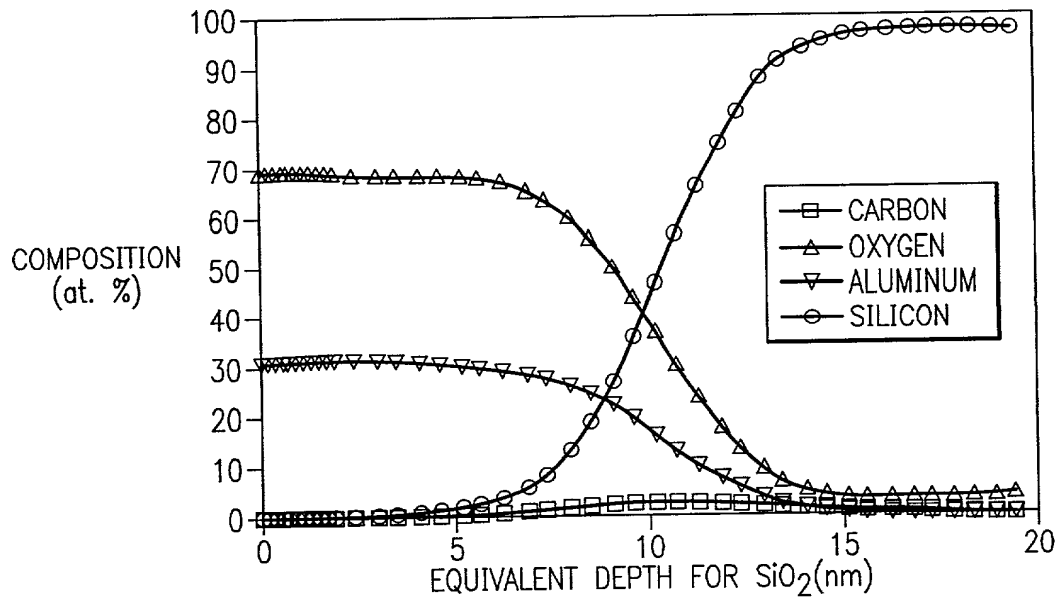


FIG. 11A

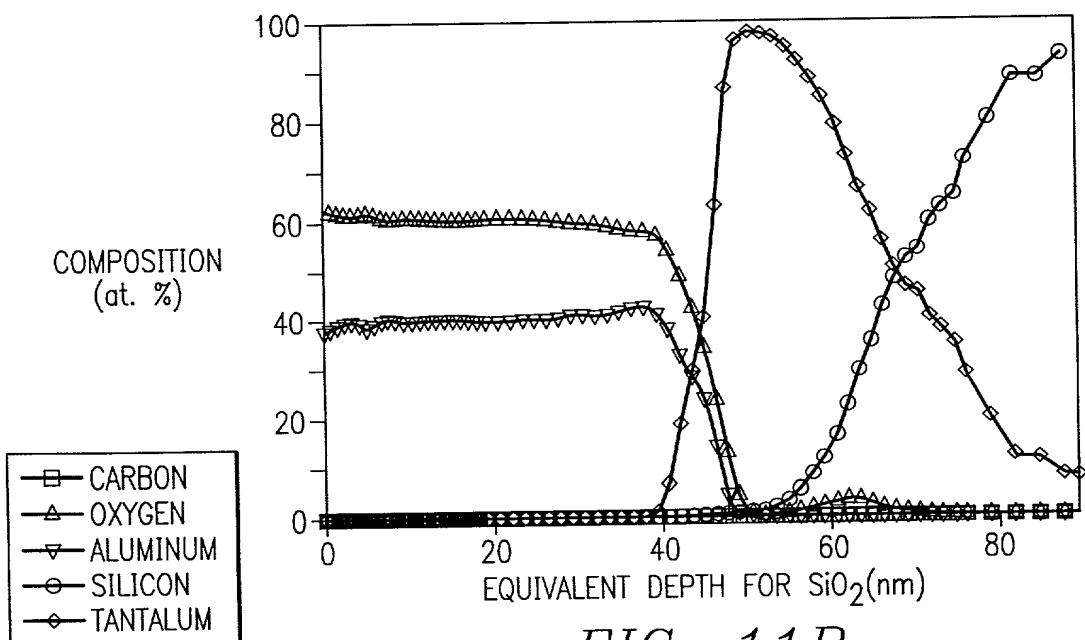


FIG. 11B